

APR 20 2000

020732-110.694 (7493)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:	Docket No.:	020732-110.694	
Applicant:	KORZENSKI, Michael B., et al.	Examiner:	AHMED, Shamim
Application No.:	10/807,858	Art Unit:	1765
Date Filed:	March 24, 2004	Confirm. No.:	5492
Title:	COMPOSITION USEFUL FOR REMOVAL OF BOTTOM ANTI-REFLECTION COATINGS FROM PATTERNED ION- IMPLANTED PHOTORESIST WAFERS		
	Customer No.: 24239		

FACSIMILE TRANSMISSION CERTIFICATE

Attn: Examiner Shamim Ahmed

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on April 20, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages (including cover)

Lillian Glenn

April 20, 2006

Date _____

**SUBMISSION OF POWER OF ATTORNEY AND STATEMENT UNDER 37 CFR 3.73(b)
AND AMENDMENT RESPONDING TO MARCH 21, 2006 OFFICE ACTION IN
UNITED STATES PATENT APPLICATION NO. 10/807,858**

**Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450**

Sir:

This responds to the March 21, 2006 Office Action in the above-identified application.

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Please amend the claims of the application as set out in the following **Section I (Amendments to the Claims)**.

Remarks addressing the substance of the March 21, 2006 Office Action are set out in the **Section II (Remarks)** hercof.